

In re PATENT application of:

Hisashi OHTANI et al.

Application No.: 08/807,737

Filed: February 27, 1997

For: METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

Art Unit: 2829

Examiner: Evan PERT

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AUG 26 2003

OFFICE OF PETITIONS

**PETITION FOR WITHDRAWAL FROM ISSUE
UNDER 37 C.F.R. 1.313(c)(2)**


**Mail Stop Petition
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

Sir:

Applicants hereby petition for the withdrawal of this application from issue, under 37 C.F.R. 1.313(c)(2), to consider the Request for Continued Examiner, pursuant to 37 C.F.R. 1.114, as well a Preliminary Amendment and a Information Disclosure Statement, filed on even date herewith. The issue fee for this case was paid on July 8, 2003.

The Commissioner is authorized to charge any deficiencies (except the issue fee) or credit any overpayment to Deposit Account No. 19-2380 (740756-1638). A duplicate copy of this sheet is attached.

Respectfully submitted,


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